Atty. Dkt. No. APPM/007989/ETCH/SILICON/PJS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Liu, et al.

Patent No.: 10/665,934

Issued:

June 28, 2005

Serial No.: 10/665,934

Filed:

September 19, 2003

For:

Method of Controlling

Critical Dimension

Microloading of Photoresist

Trimming Process by

Selective Sidewall Polymer

Deposition

Certificate of Correction Branch Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

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Examiner:

George Fourson

Certificate

FEB 2 1 2006

of Correction

CERTIFICATE OF MAILING

37 CFR 1.8

I hereby certify that this correspondence is being deposited on February 7, 2006 with the United States Postal Service as First Class Mail in an envelope addressed to: Certificate of Correction Branch, Commissioner for Patents, P.O. Box 1450

Alexandria, VA 22313-1450, February 7, 2006

Signature

REQUEST FOR CERTIFICATE OF CORRECTION

Attached is a Certificate of Correction for correcting several errors throughout the printed patent.

Applicants submit that the errors mentioned above were not by the applicant, but were made during the printing of the patent.

Respectfully submitted,

Keith M. Tackett

Registration No. 32,008

PATTERSON & SHERIDAN, L.L.P.

3040 Post Oak Blvd. Suite 1500

Houston, TX 77056

Telephone: (713) 623-4844 Facsimile: (713) 623-4846

Agent for Applicant(s)

UNITED STATES PATENT AND TRADEMARK OFFICE

CERTIFICATE OF CORRECTION

PATENT NO: 6,911,399 B2

Page <u>1</u> of <u>1</u>

APPLICATION NO.: 10/665,934 DATED: September 19, 2003

INVENTOR(S): Wei LIU, David MUI

It is certified that error appears in the above-identified patent and that said Letters Patent are hereby corrected as shown below:

In the Specification

Column 2, Line 15: Change "to leave" to "gas mixture to etch"

Column 2, Line 39: Change "integrate" to "integrated"

In the Claims

Column 8, Line 7: Change "claim 3" to "claim 1"

Column 8, Line 14: Change "scorn" to "sccm"

MAILING ADDRESS OF SENDER (Please do not use customer number below):

B. Todd Patterson Patterson & Sheridan LLP 3040 Post Oak Boulevard, Suite 1500 Houston, TX 77056

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